

SpotOn 位敏探测系统



新势力光电供应**SpotOn位敏探测系统**，光谱范围 350-1100nm 、位置精度 $\pm 0.1\mu\text{m}$ 或者光束尺寸 $\pm 0.025\%$ 。该系列**位敏探测系统**用于测量：激光中心/位移/功率的测量、光学系统准直及品质控制、旋转及位移的测量、平面度及准直性的校准、振动及缺陷的监控。

Model	Descriptions
SPOTUSB-L	Lateral effect PnP 9mm×9mm, no glass cover
SPOTUSB-N	Lateral effect PnP 10mm×10mm, with glass cover
SPOTUSB-Q	Four quadrant PnP 10mm×10mm, with 30um gap, no glass cover
SPOTUSB-U	Four quadrant PnP 10mm×10mm, with 10um gap, with glass cover
SPOTON-LA	Large aperture, 135mm×100mm, 400-800nm
<i>Optional heads</i>	
L44	Lateral effect PnP, usable beam size<25mm
L18	Lateral effect PnP 18mm×18mm, with glass cover
L4	Lateral effect PnP 4mm×4mm, no glass cover
<i>Optional accessories</i>	
NG4	ND filter in housing (3/4"-32 thread)
NG9	ND filter in housing (3/4"-32 thread)
NG10	ND filter in housing (3/4"-32 thread)
Hood	55mm long, for ambient light suppression

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